



Inventor(s):
Halimaoui et al.

Title: PROCESS FOR FORMING
AN OXIDE LAYER OF
NON-UNIFORM
THICKNESS ON THE
SURFACE OF A SILICON
SUBSTRATE

Examiner: Novacek, Christopher
Group/Art Unit: 2822
Atty. Dkt. No: 5310-03000

CERTIFICATE OF MAILING
UNDER 37 C.F.R. §1.8

DATE OF DEPOSIT: 11-8-08

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail on the date indicated above and is addressed to:

Commissioner for Patents
Washington, DC 20231

Jackie L. Pitre

PETITION UNDER 37 C.F.R. §1.136
FOR EXTENSION OF TIME

Commissioner for Patents
Washington, D.C. 20231

Sir:

Applicant respectfully petitions the Commissioner for a one month extension of time under 37 C.F.R. §1.136 within which to respond to the Final Official Action mailed July 10, 2002.

If any fees are omitted or if any additional fees are required or have been overpaid, please appropriately charge or credit those fees to Conley, Rose & Tayon, P.C. Deposit Account Number 50-1505/5310-03000/EBM.

Respectfully submitted,

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